

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): **Satoh, Yoshihiro**

Serial No.: **09/981,402**

Filed: **October 17, 2001**

Title: **Semiconductor Device and Method
for Its Manufacture**

Attorney Docket No.: **N32040200W**

Group Art Unit: **2815**

Examiner: **Richards, N. Drew**

(N.E)
11/Response
J. Steptoe
2/12/03

RESPONSE TO FINAL OFFICE ACTION

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Commissioner for Patents
P.O. Box 1450
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A. Introductory Comments

The following is submitted in response to the FINAL Office Action dated March 4, 2003.
The two month Advisory Action Period ends May 5, 2003.

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This response is presented in the revised amendment format set forth in 1265 Off. Gaz.
Pat. Office 87 (Dec. 17, 2002) and so is subject to waiver of the provisions of 37 C.F.R. §1.21(a),
(b) and (c).

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37 C.F.R. §1.8

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